



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re F	Patent Application of:	)	Group Art Unit: 2826	
Ritsuk	ko KAWASAKI et al.	)	Examiner: Ahmed N. Sefer	
Serial	No. 10/625,904	)	CERTIFICATE OF MAILING I hereby certify that this correspondence is	
Filed: July 24, 2003		)	being deposited with the United States Postal Service with sufficient postage as First Class	
For:	SEMICONDUCTOR DEVICE AND	)	Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450,	
	METHOD OF FABRICATING THE	)	Alexandria, VA 22313-1450, on 5.30.2006.	
	SAME	)	add m Otamou	

## <u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated February 10, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.